

STEV

DEMARK SE AMEN	NDMENT 7	ΓRANSMI	TTAL LE	TTER	Docket No 8733.213.0	-	
Application No.		Filing	Date	Examiner	Art Unit		
09/497,508		February 4, 2000		Wai Sing Lou			
Applicant(s): JAN	IG, Jin et al.						
nvention: POLYC	RYSTALLINE	SILICON FILM	M CONTAINII	NG Ni			
		THE COMMI					
Transmitted here The fee has been				• •			
		CLAIM	S AS AMENI	DED			
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate			
Total Claims	11	- 20 =		x			
Independent Claims	2	- 4 =		×			
Multiple Depend	lent Claims (ch	eck if applicabl	e)		_		
Other fee (pleas	e specify):						
TOTAL ADDIT	IONAL FEE FO	OR THIS AME	NDMENT:				
x Large Entity				Small Entity			
x No additiona	Il fee is require	d for this amer	ndment.				
Please charg	ge Deposit Acc	count No	ir	n the amount of \$ _		- ·	
A check in th	ne amount of \$		to cover	the filing fee is enclo	osed.		
Payment by	credit card. Fo	orm PTO-2038	is attached.				
	is hereby auth I below. A dup			Deposit Account No enclosed.	50-0911	_	
x Credit ar	ny overpaymer	nt.					
x Charge a			n processing f	ees required under 3	7 CFR 1.16 and 1	.17.	
Valoue P.	Hayes!	Zey-No. 53,005		Dated:F	February 1, 2005	1	
Attorney Reg. N	lo.: 51,640						
	~ .						



Docket No.: 8733.213.00

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jin Jang et al.

Customer No.: 30827

Application No.: 09/497,508

Confirmation No.: 7572

Filed: February 4, 2000

Art Unit: 2814

For: POLYCRYSTALLINE SILICON FILM

Examiner: W. S. Louie

CONTAINING Ni

MS Amendments Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated November 1, 2004, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.